

MEI Retrofits a Universal Systems Full Auto Linear Wet Station *Retrofit provides performance enhancements*

Albany, OR. May 2, 2007 – MEI LLC recently received an order to retrofit another Universal Systems full auto linear wet station used for immersion batch processing. This order comes on the heels of a similar successful retrofit at a different location for this same semiconductor manufacturer. The system is being retrofitted due to reliability issues and obsolete components which were threatening uptime and production capacity.

Dan Cappello, CEO of MEI said “We are very pleased to receive this repeat order as it demonstrates an expansion of trust in MEI across additional sites within the organization. We have earned their trust through our excellent execution of earlier retrofit projects at other sites and look forward to furthering our business relationship throughout their many additional sites worldwide. Our IDX automation software platform coupled with hardware engineering solutions has had a tremendous positive impact on our customers’ production lines and we are very proud of the excellent execution our team has provided”.

About MEI LLC

MEI is a diversified manufacturing and service company serving the semiconductor and high technology industries. The company’s specialties include wet process systems and services; robotics automation software; process tool rigging and crating services; clean room safety, ergonomic and support equipment; as well as a variety of manufacturing services, including machine, metal and plastic fabrication and powder coating. MEI was founded in 1990 and currently employs more than 100 people. For more information about MEI, visit www.meillc.com.